

## Special Issue

# Digital Holography and 3D Display

### Message from the Guest Editors

Display technology fundamentally transforms how humans perceive and interact with information across physical and virtual environments. With rapid advancements in algorithms and materials, digital display technology overcomes the intrinsic limitations of conventional optical systems in terms of physical architecture and performance and achieves unprecedented levels of visual fidelity, immersion, and interactivity. Furthermore, recent advances in deep learning have further accelerated the development of digital display technologies, enabling real-time, high-resolution, realistic 3D visualization and facilitating their applications in related fields, such as virtual reality, augmented reality, etc. This Special Issue is centered on digital holography and 3D display technology. Topics of interest include, but are not limited to, the following: holographic display; light field display; deep learning and artificial intelligence for digital display; material and system for digital display; virtual reality and augmented reality. **Keywords:** 3D display, holography, deep learning, metasurface, virtual reality, augmented reality

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### Editor-in-Chief

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